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|---|--|-----------------------------------|---------|---------------------------------|---------------|-------------------------------|
| <b>INFORMATION DISCLOSURE<br/>STATEMENT BY APPLICANT</b><br><br>(Use as many sheets as necessary)   |  | Application <b>10/521,891</b>     |         | OFGS File No. <b>P/2107-261</b> |               |                               |
|   |  | Applicant <b>Tillmann Dorr</b>    |         |                                 |               |                               |
|   |  | Filing Date <b>April 18, 2005</b> |         | Group Art Unit <b>1794</b>      |               |                               |
| <b>U.S. PATENT DOCUMENTS</b> (not submitted for applications filed after 6/30/03)   |  |                                   |         |                                 |               |                               |
| Examiner<br>Initial   | Document Number  | Date<br>MM-YYYY                   | Name    | Class                           | Sub-<br>class | Filing Date<br>If Appropriate |
| /AW/  | US-4,732,773   | 03-1988                           | Schott  |                                 |               |                               |
|   | US-  |                                   |         |                                 |               |                               |
|   | US-  |                                   |         |                                 |               |                               |
|   | US-  |                                   |         |                                 |               |                               |
| <b>FOREIGN PATENT DOCUMENTS</b>   |  |                                   |         |                                 |               |                               |
|   | Document Number  | Date<br>MM-YYYY                   | Country | Class                           | Sub-<br>class | Translation<br>Yes      No    |
|   | 58-031961  | 02-1993                           | Japan   |                                 |               | X<br>(abstract)               |
|   | 59-28457<br>(corresponding to USP<br>4,732,773)  | 02-1984                           | Japan   |                                 |               | X                             |
|   | 62-503033<br>(corresponding to WO<br>86/06625)   | 12-1987                           | Japan   |                                 |               | X                             |
|   | 2000-041639  | 02-2000                           | Japan   |                                 |               | X<br>(abstract)               |
|   | 2002-501733<br>(corresponding to WO<br>99/38393)   | 01-2002                           | Japan   |                                 |               | X                             |
|   | WO 86/06625<br>(corresponding to   | 11-1986                           | WIPO    |                                 |               |                               |
|   | /AW/ WO 99/38393   | 08-1999                           | WIPO    |                                 |               |                               |
| <b>OTHER DOCUMENTS</b> (Including Author, Title, Date, Pertinent Pages, Etc.)   |  |                                   |         |                                 |               |                               |
|   | English translation of Japanese Official Action dated December 16, 2008 corresponding to Japanese Patent Application No. 2004-522523 |                                   |         |                                 |               |                               |
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|   |  |                                   |         |                                 |               |                               |
| /Anthony Weier/   |  | 4/25/09                           |         |                                 |               |                               |
| Examiner  |  | Date Considered                   |         |                                 |               |                               |
| EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant. |  |                                   |         |                                 |               |                               |